

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. .... 10/208,154  
Priority Filing Date ..... July 29, 2002  
Inventor..... Jerome M. Eldridge  
Assignee..... Micron Technology, Inc.  
Priority Group Art Unit ..... 2822  
Priority Examiner ..... K. Duong  
Attorney's Docket No. ..... MI22-2395  
Title: Perovskite-Type Material Forming Methods, Capacitor Dielectric Forming Methods,  
and Capacitor Constructions

**PRELIMINARY AMENDMENT**

To: Box PATENT APPLICATION  
Attn: Art Unit 2822  
Commissioner for Patents and Trademarks  
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**AMENDMENTS**

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